

BAR CODE LABEL



## U.S. PATENT APPLICATION

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CLASS

430

GROUP ART UNIT

1503

APPLICANT

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\*\*CONTINUING DATA\*\*\*\*\*

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\*\*FOREIGN/PCT APPLICATIONS\*\*\*\*\*

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STATE OR  
COUNTRY

CA

SHEETS  
DRAWING

7

TOTAL  
CLAIMS

20

INDEPENDENT  
CLAIMS

3

FILING FEE  
RECEIVED

\$710.00

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ADDRESS

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TITLE

METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR  
FABRICATION PROCESSThis is to certify that annexed hereto is a true copy from the records of the United States  
Patent and Trademark Office of the application which is identified above.By authority of the  
COMMISSIONER OF PATENTS AND TRADEMARKS

Date

Certifying Officer